

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Shinji MAEKAWA et al.

Serial No.: 10/827,457

Filed: April 19, 2004

For: Method For Forming Pattern And
Drop Discharge Apparatus

Examiner: Marianne L. Padgett

Art Unit: 1792

Confirmation No.: 2984

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT I

Applicants have the following response to the Office Action of December 18, 2009.

Please amend the above-identified application as follows: